

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of

Masayoshi SHIGA, et al.

Date: February 10, 2003

Serial No.:

09/942,153

Group Art Unit: 2812

Filed:

August 29, 2001

Examiner:

Karla A. Moore

For:

SUBSTRATE PROCESSING APPARATUS, SUBSTRATE INSPECTION

METHOD AND SUBSTRATE PROCESSING SYSTEM

Assistant Commissioner for Patents Washington, D.C. 20231

PETITION AND FEE FOR AUTOMATIC EXTENSION OF TIME UNDER 37 CFR 1.17, 1.136(a) AND 35 USC 41(a)8

Sir:

Applicant(s) hereby petition(s) the Asst. Commissioner for Patents to extend the time for filing a response to the outstanding Office Action by one month. Enclosed is our check No. 15004 which includes the amount of \$110.00 for the petition fee in accordance with 37 CFR 1.17 computed as:

 $\sqrt{}$ Response within first month $\sqrt{}$ not small entity (\$110)

You are authorized to charge to our Deposit Account No. 15-0700 any additional amounts owing.

If this petition is inadequate to avoid abandonment, the Assistant Commissioner for Patents is petitioned, under 37 C.F.R. §1.136(a), to extend the time by the number of months which will avoid abandonment under 37 C.F.R. §1.135. The fee under 37 C.F.R. § 1.1.7 should be charged to our Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant. Commissioner for Patents, Washington, D.C. 20231, on February 10, 2003

Max Moskowitz

Name of applicant assignee or
Registered Representative

Signature

February 10, 2003

Date of Signature

Respectfully submitted,

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